Wavelet-denoising technique in near-infrared methane detection based on tunable diode laser absorption spectroscopy^{*}

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A novel wavelet denoising (WD) assisted wavelength modulation technique is proposed for improving near-infrared detection performance on methane concentration based on tunable diode laser absorption spectroscopy (TDLAS). Due to the ability of multi-level analytical resolutions both in time- and frequency-domains, the noise contained in the differential signal is greatly suppressed. Sensor mechanical part, optical part and electrical part are integrated, and a portable detection device is finally developed. Theory and formulations of the WD-assisted wavelength modulation technique are presented, and experiments are carried out to prove the normal function on the extraction of the second harmonic (2*f*) signal from severely polluted differential signal by using the technique. By virtue of WD's suppression on noises, the sensing characteristics on CH_4 concentration are improved, and the limit of detection (LOD) is decreased from 4×10^{-6} (without WD processing) to 10^{-6} . The proposed technique can also be used for the measurement on the concentration of other gases with corresponding near-infrared distributed feedback lasers.

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For consideration of safe production in coal mine industrial environment, the research in the field of CH₄ detection^[1-4] shows the same increasing trend as the detection on other trace gases, including NO, CO, SO₂, etc. Owning to the advantages, including wide measuring range, high sensitivity, good selectivity, longevity and fast response, the spectrum absorption becomes a well-known technique on CH₄ detection^[5-7]. Tunable diode laser absorption spectroscopy (TDLAS) can overcome the above disadvantages and satisfy more difficult measurement requirements, and it has been widely used in infrared trace gas detection^[8-11]. As a superior signal processing technique, wavelet denoising (WD)^[12-14], which possesses multi-level analytical resolutions both in time- and frequency-domains, is an efficient tool to remove noises from severely polluted signal. In this paper, a CH₄ detection device based on WD-assisted wavelength modulation technique is experimentally demonstrated. By doing wavelet transformation on polluted differential signal between detection channel and reference channel, the

expansion coefficients under different levels are obtained. The noises, whose expansion coefficients are different from those of the pure signal, can be removed through the self-adaptive multi-threshold WD method.

The configuration of the proposed CH₄ detection device is shown in Fig.1, which generally contains two parts. The optical part is configured with a gas-cell, a near infrared (NIR) TDL source and two NIR detectors. The electrical part is equipped with an electric board for driving, modulating and temperature-controlling of the TDL, dealing with sensing signals and performing data-processing, calculation and displaying. The generated laser beam is split into two beams with a fiber optical beam splitter (FOBS). The reference laser beam firstly propagates through an optical attenuator (OA), and then reaches the reference NIR-detector for generating the reference current i_{i} ; the detection laser beam passes into the gas cell through a fiber collimator (FC), then propagates out of the gas cell through another FC, and finally the absorbed beam reaches the detection

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NIR-detector for generating the detection current $i_{\rm d}$. $i_{\rm r}$ and $i_{\rm d}$ are transformed to voltage signals through the bias circuits, denoted by $u_{\rm r}$ and $u_{\rm d}$. After subtraction and full-scale selection (FS-S), the differential signal $u_{\rm d=} = u_{\rm r} - u_{\rm d}$ is sampled by a 16-bit ADC and converted to digital signal.



Fig.1 Configuration of the proposed CH₄ detection device using WD-assisted wavelength modulation technique

The scan and modulation signal used to drive the DFB laser is

$$u(t) = u_{\text{saw}}(t) + u_{\text{cos}}(t), \qquad (1)$$

where $u_{saw}(t) = (A_{jc}/2) \left[1 + 2f_{jc}(t - T_{jc}/2) \right]$, $u_{cos}(t) = (A_{cos}/2) \cos(\omega_{cos}t)$ and $T_{jc} = 1/f_{jc}$. Under the operation of u(t), the emitting light intensity distribution over the 2-D plane and the absorption coefficient are

$$I(x, y, t) = nI_0 [1 + mu(t)] f(x, y), \qquad (2)$$

$$\alpha(t) = \frac{\alpha_0}{1 + \left[\left(v_0 - v_g \right) / \gamma + \delta u(t) / \gamma \right]^2}, \qquad (3)$$

where f(x, y) is the 2-D normalized distribution function of light intensity, I_0 is the central emitting light intensity, mis light modulation coefficient, v_g is central absorption wave-number, v_0 is central emitting light wave-number determined by the operation temperature of DFB laser, δ is light wavelength modulation coefficient, $\alpha_0 = \frac{N_0 S}{\pi \gamma}$ is the light absorption coefficient at v_0 , S is the light absorption intensity at v_0 , γ is the half-width of the absorption peak at v_0 , and N_0 is the Avogadro's constant.

Let gas concentration be C, and absorption path length be L. Considering residual amplitude modulation, for the detection channel, based on Beer-Lambert law, the radiation intensity distribution over the sensing plane $S_{\rm D}$ can be expressed as Optoelectron. Lett. Vol.10 No.4

$$I_{t}(x, y, t) = nI_{0}f(x, y)[1 + mu(t)]\exp[-\alpha(t)CL] =$$
$$nI_{0}f(x, y)[1 + mu(t)][1 - \alpha(t)CL], \qquad (4)$$

where *n* is the attenuation coefficient of OA, and $\alpha(v,t)$ is the absorption coefficient dependent on the emitting wavelength of DFB laser. The emitting light is simply regarded to be perpendicular with the sensing plane, and the total radiation intensity to detector #1 is

$$\Psi_{t}(v,t) = nI_{0}\left(\iint_{S_{0}} f(x,y) \,\mathrm{d}x \mathrm{d}y\right) \times \left[1 + mu(t)\right] \left[1 - \alpha(v,t) \,CL\right].$$
(5)

For the reference channel, the total radiation intensity reaching detector #2 is

$$\psi_{r}(v,t) = (1-n)I_{0}\left(\iint_{S_{0}} f(x,y) \,\mathrm{d}x \,\mathrm{d}y\right) \left[1 + mu(t)\right]. \tag{6}$$

Let $G = \iint_{S_0} f(x, y) dxdy$. After optical-to-electrical conversion and being amplified, the two signals will be modified to

$$u_{t}(t) = K_{t}D_{oc}^{t}GnI_{o}\left[1 + mu(t)\right]\left[1 - \alpha(v,t)CL\right], \quad (7)$$

$$u_{r}(t) = K_{r}D_{o}^{r}G(1-n)I_{0}\left[1+mu(t)\right],$$
(8)

where K_t and D_{oe}^t are the amplifying factor and opticalto-electrical conversion coefficient for the detectionchannel, respectively, and K_r and D_{oe}^r are those for the reference-channel, respectively. The differential signal between u_t and u_r is

$$u_{r}(t) - u_{t}(t) = I_{0}[1 + mu(t)][K_{r}D_{\infty}^{r}G(1 - n) - K_{t}D_{0c}^{t}Gn + K_{1}D_{0c}^{t}Gn\alpha(t)CL].$$
(9)

Tuning the attenuation coefficient *n*, we have $K_r D_{\infty}^t G \times (1-n) - K_t D_{\infty}^t G n = 0$. With the satisfaction of mu(t) << 1, Eq.(11) will be changed to

$$u_{_{\rm r}}(t) = u_{_{\rm r}}(t) - u_{_{\rm t}}(t) = K_{_{\rm t}} D_{_{\rm oe}}^{_{\rm t}} Gn\alpha(t) CL .$$
(10)

By using an ADC, the analogue signal $u_{\pm}(t)$ is converted to discrete digital signal $u_{\pm}(k)$ as

$$u_{d=}(k) = K_{t} D_{\infty}^{t} Gna(kT_{s})CL, \qquad (11)$$

where T_s is sampling period.

Considering the noises and interferences (defined by n(k)) introduced by electric circuits, the signal should be expressed as

$$u'_{d=}(k) = u_{d=}(k) + n(k).$$
(12)

With Fourier transformation, the second harmonic (2f) signal can be achieved by the following numerical integral

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$$S_{2f}(k) = \sum_{n=k-N_{m}}^{k} \left[u'_{d}(n) \cos(2\omega_{cos} nT_{s}) \right].$$
(13)

Without WD processing, the differential signal contains too many noises, as shown by the lower trace in Fig.2, and the extracted 2f signal reveals fluctuation, as shown by the upper trace in Fig.2. The situation becomes even worse when the concentration gets further lower. This will deteriorate the detection performance. Therefore, as an innovation of this paper, inside the DSP, the sampled differential signal is firstly digitally processed with WD, namely

$$u''_{d=}(k) = WD \left[u'_{d=}(k) \right].$$
⁽¹⁴⁾

Then, Eq.(13) is used to extract the 2f signal.



Fig.2 Observed waveforms of the differential signal and 2*f* signal under (a) 1% concentration and (b) 0.05% concentration

The wavelet denoising principle is described below. Let $\varphi_{jk}(t) = 2^{-j/2} \varphi(2^{-j}t - k)$ be the sub-wavelet function obtained by the transformation on the mother wavelet function $\varphi(t)$, and let h(n) and $g(n), n = 0, 2, \dots, N-1$, be the high-pass and low-pass weighting coefficients of $\varphi(t)$. For the discrete differential signal $c_n^0 = u_{d,=}(n), n = 0, 2, \dots, M-1$, the *j*-th discrete wavelet transformation (DWT) on $u(c_n^j$ and d_n^j , $j = 0, 1, \dots, J-1$) can be regarded as the expansion on the (j-1)-th discrete wavelet transformation (DWT) on $u(c_n^{j-1})$, which is written as

$$c_{k}^{j+1} = \sum_{n \in \mathbb{Z}} h(n) c_{2k+n}^{j} , \qquad (15)$$

$$d_{k}^{j+1} = \sum_{n \in \mathbb{Z}} g(n) c_{2k+n}^{j} .$$
 (16)

For the *j*-th deposition, define the lengths of c^{j} , d^{j} ,

 $\boldsymbol{d}^{j-1}, \cdots, \boldsymbol{d}^{1}$ as $k_{j,\max}, k_{j,\max}, k_{j-1,\max}, \cdots, k_{1,\max}$.

Before recovering the original data using inversion DWT (IDWT), the expansion coefficients should be processed for the suppression on contained noises. Because the frequent components of $u_{d_{-}}(n)$ are complicated, the denoising is carried out considering the coefficient correlations both inside the same deposition scale and between different deposition scales. The included WD steps are below.

(1) Given a parameter ς , calculate the coefficient

$$\lambda = \frac{\sqrt{2 \ln M}}{\zeta k_{1,\max}} \sum_{k=0}^{k_{1,\max}-1} d_k^1 \, .$$

(2) At the *j*-th wavelet deposition scale, define the weighting coefficient vector as $\boldsymbol{w}_j = [\boldsymbol{c}^j, \boldsymbol{d}^j, \boldsymbol{d}^{j-1}, \cdots \boldsymbol{d}^1]$, and construct a coefficient matrix as $\boldsymbol{W} = [\boldsymbol{w}_1, 0, \cdots, 0; \boldsymbol{w}_2, 0, \cdots, 0;$ $\cdots \boldsymbol{w}_j]^T$. Note that, the length of \boldsymbol{w}_j is shorter than that of \boldsymbol{w}_{j+1} , so '0' elements are supplemented to make the length of each sub-vector of the matrix be equal.

(3) Determine the matrix
$$m_{j,k}$$
, whose elements are

$$nn_{j,k} = \begin{cases} \sqrt{W_{j,l}^2 + W_{j,2}^2}, k = 1 \\ \sqrt{W_{j,k-1}^2 + W_{j,k}^2 + W_{j,k+1}^2}, 1 < k < k_{j,\max} \end{cases}$$
. Calculate the

$$\sqrt{W_{j,k_{j,\min}-1}^2 + W_{j,k_{j,\min}}^2}, k = k_{j,\max}$$

binaration matrix \vec{u} , whose elements are $ii_{j,k} = \begin{cases} 1, nn_{j,k}^2 > \lambda^2, W_{j,k} \frac{1-\lambda^2}{nn_{j,k}^2} \neq 0 \\ nn_{j,k}^2 \end{cases}$, and calculate the dif-

0, otherwise

ferential matrix *ee* based on *ii*, whose elements are $ee_{i,k} = \begin{cases} ee_{j,k}, k = 1 \\ ee_{i,k} \end{cases}$

$$ee_{j,k} - ee_{j,k-1}$$
, otherwise.

(4) Obtain the index matrices *aa* and *bb*, whose elements satisfy $aa_{j,m} = k\Big|_{e_{m,n}=1}$ and $bb_{j,m} = k\Big|_{e_{m,n}=1}$.

(5) Determine the horizontal correlation matrix *hh* inside the same deposition scale, whose elements are $hh_{j,k} = \begin{cases} bb_{j,m} - aa_{j,m}, k > aa_{j,m} \text{ and } k < bb_{j,m} \\ 0, \text{ otherwise} \end{cases}$. Determine

the vertical correlation matrix *vv* between different deposition scales, whose elements are $vv_{j,k} = \begin{cases} ii_{j,k} \times ii_{j+1,k}, j < J\\ ii_{j,k}, j = J \end{cases}$.

(6) Determine the decision coefficient matrix *dd* considering horizontal and vertical coefficients, and its elements are $dd_{j,k} = \begin{cases} 1, vv_{j,k} = 1 \text{ or } hh_{j,k} > h_{thr} \\ 0, \text{ otherwise} \end{cases}$, where h_{thr}

is the threshold value of the horizontal correlation element, which is set to be an integer within 3-7.

(7) Calculate the new wavelet deposition coefficient matrix \tilde{W} , whose elements are $\tilde{W}_{i,j} = W_{i,j} \times dd_{i,j}$.

(8) For the *j*-th deposition, $\tilde{c}_k^j = \tilde{W}_{j,k}$, $\tilde{d}_k^j = \tilde{W}_{j,k+k_{j,\text{max}}}$,

 $\tilde{d}_k^{j-1} = \tilde{W}_{j-1,k+\sum_{i=j}^{l-2}k_{i,\max}}, \dots, \tilde{d}_k^1 = \tilde{W}_{j-1,k+\sum_{i=j}^{2}k_{i,\max}}.$ Then recover the

original data c_k^0 by performing $c_k^{j-1} = \sum_k \tilde{c}_k^j h_{n-2k} +$

 $\sum_{k} \tilde{d}_{k}^{j} g_{n-2k} \quad \text{for } j \text{ interactions. Denote } c_{k}^{0} \text{ obtained from}$

the *j*-th wavelet construction as $c_k^{j,0}$.

(9) An average value is finally adopted to evaluate the

original data as
$$\tilde{u}_{d,=}(k) = \tilde{c}_k^0 = \frac{1}{J} \sum_{j=1}^{\infty} \tilde{c}_k^{j,0}$$
.

Experiments are carried out to verify the proposed WD method. The differential signal is sampled, and the sampled dot number per period is $M=20\,000$. C-language-based WD program using CCS 3.0 platform is compiled for the DSP. The selected mother-wavelet function is 'db9' and the wavelet deposition scale is J=4. The data of the differential signal, denoised signal and the extracted 2f signal are sent to a computer via UART communication port for data storage and observation.

For the sub measurement scale of $0-10^{-3}$, Fig.3 shows the WD processing results on the measured differential signals under the concentrations of 10^{-5} , 5×10^{-6} , 2×10^{-6} and 10^{-6} , respectively. It can be found that after WD processing, the noises are sufficiently suppressed. In Figs.3(a) and (b), the fluctuations of the two 2f signals almost disappear compared with those without using WD, and this will be helpful for enhancing detection stability. In Figs.3(c) and (d), before WD processing, the 2f signals cannot be extracted; however, after WD processing, the waveforms of the two 2f signals are well observed with small noises, and this will be helpful for improving the MDL and sensitivity.

The limit of detection (LOD) and sensitivity under the situations of using WD and without using WD are mainly dependent on the noise levels under the two cases. At an initial concentration, the detection sensitivity can be regarded as the minimum CH₄ concentration change producing a variation in the amplitude of 2f signal which can be obviously recognized by the system. Experiment was done below. The gas sample with an initial concentration was firstly prepared; then the concentration was slightly modified by injecting a proper amount of pure CH₄ until the minimum detection amplitude was steadily lower than the maximum detection amplitude under the initial concentration. Note that, after each CH₄ injection, 30 detections on the amplitude of the 2f signal were conducted. Under extremely low concentration range, Fig.4 shows the detected amplitude of the 2f signal within $0-10^{-5}$, where the concentration is slightly increased by 10^{-6} . We can find from Fig.4(b) that when WD is unused, the variation ranges of the detected amplitude under 0, 10^{-6} , 2×10^{-6} and 3×10^{-6} are overlapped with each other because of noises, and as the concentration increases to 4×10^{-6} , the minimum detected amplitude begins to be larger than the maximum detected amplitude under 0. Thus the MDL in this case is about 4×10^{-6} . When WD is used (Fig.4(a)), because the noise level is minimized, the MDL is improved to about 10^{-6} .

Additionally, within this range, the detection sensitivity is decided to be about 2×10^{-6} under both two cases.



Fig.3 For the sub measurement scale of $0-10^{-3}$, the measured differential signals and the extracted 2f signals under the concentrations of (a) 10^{-5} , (b) 5×10^{-6} , (c) 2×10^{-6} , and (d) 10^{-6} , respectively

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Fig.4 The detected amplitudes of the 2f signals within 0—10⁻⁵ concentration under the cases of (a) using WD and (b) without using WD, where 30 detections are performed for one gas sample

As a conclusion, a novel WD-assisted wavelength modulation technique is proposed for improving detection performance on methane concentration based on TDLAS, and due to the ability of multi-level analytical resolutions both in time- and frequency-domains, the noise contained in the differential signal is greatly suppressed. Experiments are carried out to prove the normal function on the extraction of 2f signal from severely polluted differential signal using the proposed technique. By virtue of WD's suppression on noises, the sensing characteristics on CH_4 concentration are improved through experiment.

References

- S. L. Bai, L. Y. Chen, P. C. Yang, R. X. Luo, A. F. Chen and C. L. Chung, Sensors and Actuators B: Chemical 135, 1 (2008).
- [2] A. Kock, A. Tischner, T. Maier, M. Kast, C. Edtmaier, C. Gspan and G. Kothleitner, Sensors and Actuators B: Chemical 138, 160 (2009).
- [3] Y. Zhang, W. Gao, Z. Song, Y. An, L. Li, Z. Song, W. W. Yu and Y. D. Wang, Sensors and Actuators B: Chemical 147, 5 (2010).
- [4] J. Liu, Q. Tan, W. Zhang, C. Xue, T. Guo and J. Xiong, Measurement 44, 823 (2011).
- [5] U. Willer, M. Saraji and A. Khorsandi, Optics and Lasers in Engineering 44, 699 (2006).
- [6] A. Zybin, J. Koch and D. J. Butcher, Journal of Chromatography A 1050, 35 (2004).
- [7] G. J. Zhang and X. L. Wu, Optics and Lasers in Engineering 42, 219 (2004).
- [8] Z. Peng, Y. Ding, L. Che, X. Li and K. Zheng, Optics Express 19, 23104 (2011).
- [9] Philip A. Martin, Chem. Soc. Rev. **31**, 201 (2002).
- [10] G. Durry, J. S. Li, I. Vinogradov, A. Titov, L. Joly, J. Cousin, T. Decarpenterie, N. Amarouche, X. Liu, B. Parvitte, O. Korablev, M. Gerasimov and V. Zéninari, Appl. Phys. B: Lasers and Opt. **99**, 339 (2010).
- [11] Q. Tana, W. Zhang, C. Xue, J. Xiong, Y. Ma and F. Wen, Optics & Laser Technology 40, 703 (2008).
- [12] A. Khare, U. S. Tiwary, W. Pedrycz and M. Jeon, Imaging Science J. 58, 340 (2010).
- [13] P. Gorgel, A. Sertbas and O. N. Ucan, J. Medical Systems 34, 993 (2010).
- [14] S. Gupta, R. C. Chauhan and S. C. Saxena, J. Med. Eng. Technol. 29, 208 (2005).